



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3756**

Tomohiro OKUMURA et al. : Docket No. 00177/530809

Serial No. 09/511,398 : Group Art Unit 1762

Filed February 23, 2000 : Examiner M. Padgett

PLASMA PROCESSING METHOD
AND APPARATUS :

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents,
Washington, DC 20231

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
September 20, 2002.

The fee of \$930.00 is

☒ submitted herewith.

☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

☐ Small entity status of this application is established by a Small Entity Status Assertion
which

☐ is enclosed.

☐ has been previously submitted.

03/21/2003 MDAITE1 00000124 09511398

02 FC:1253

930.00 DP

Respectfully submitted,

Tomohiro OKUMURA et al.

By

W. Douglas Hahn

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March 20, 2003

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